

FIG. 1
(PRIOR ART)

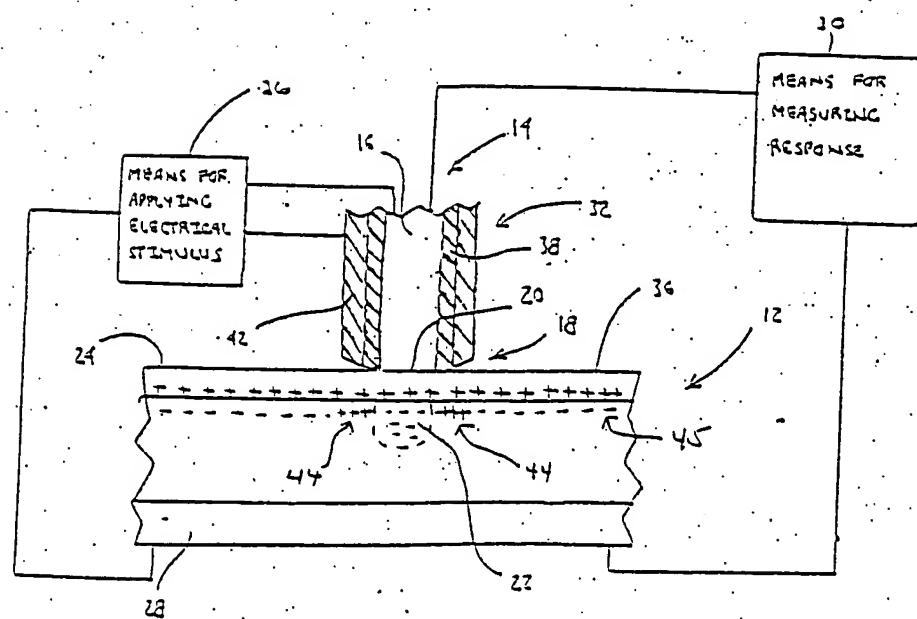


FIG. 4

Inventor: William H. Howland
"APPARATUS FOR DETERMINING DOPING CONCENTRATION OF A SEMICONDUCTOR WAFER"
Attorney Docket No.: 1880-031286

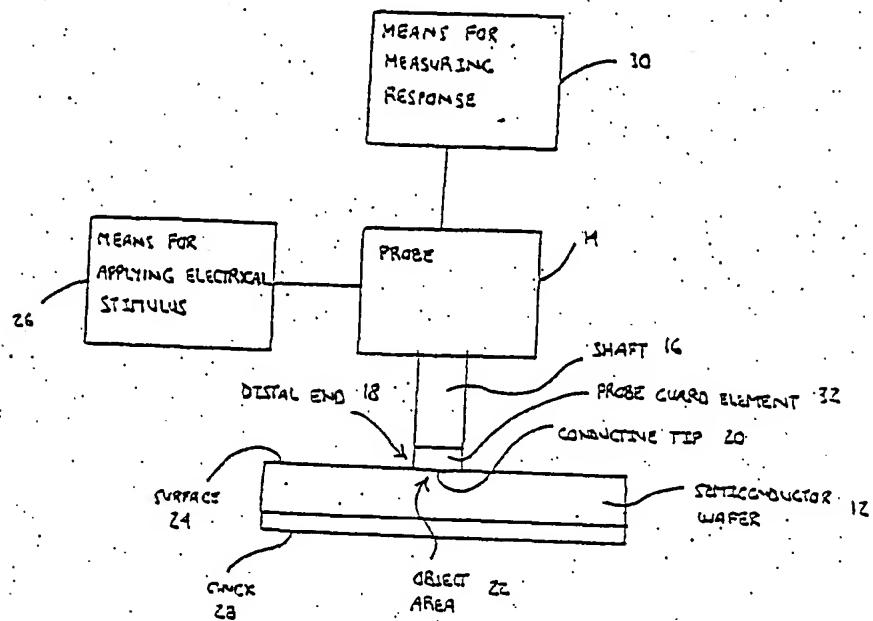


FIG. 2

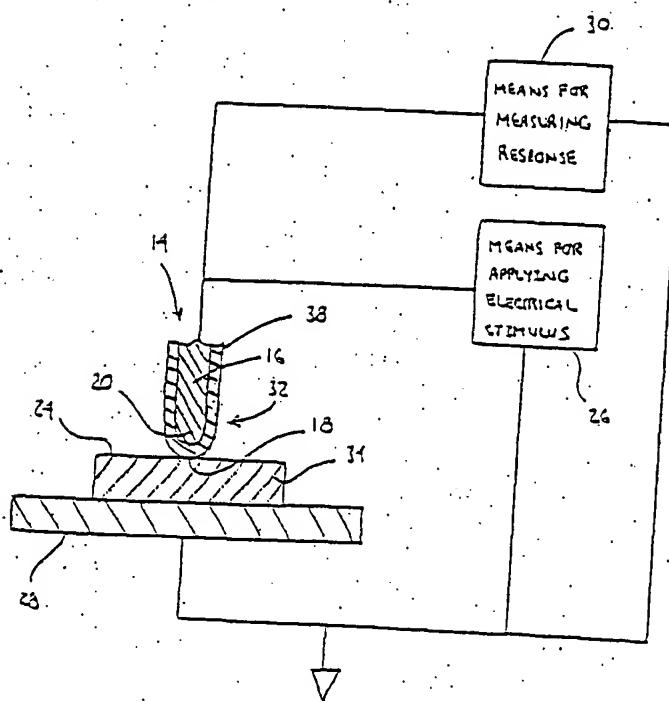


FIG. 3

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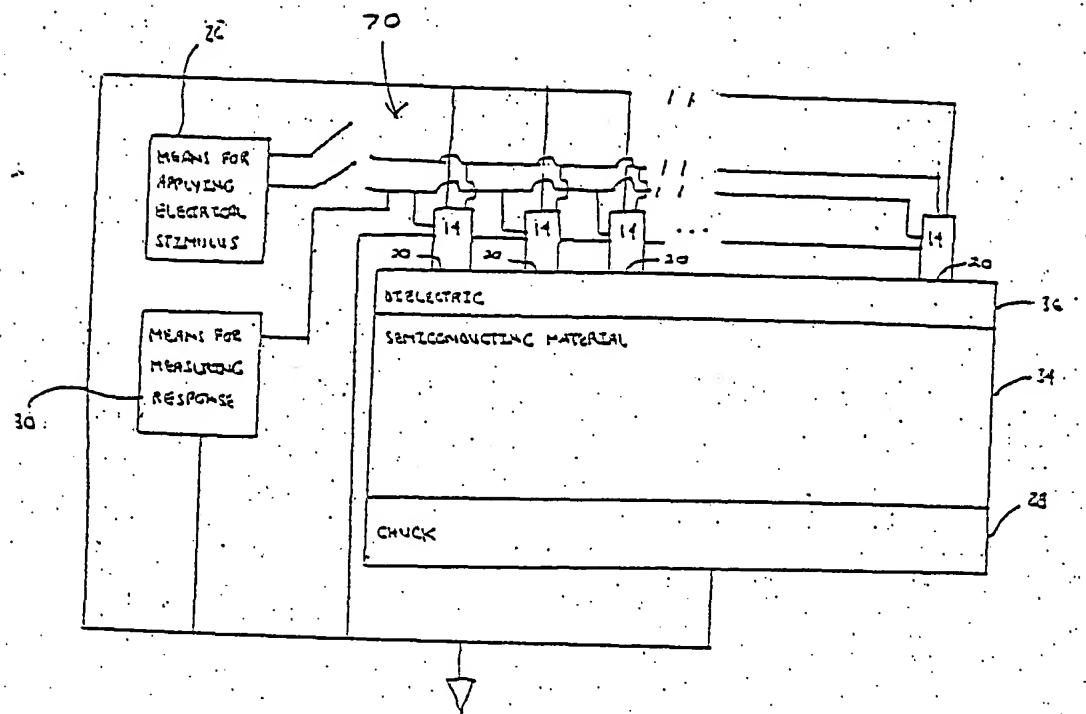


FIG. 5

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FIG. 6

